

# Impedance Estimates and Requirements for the PS2

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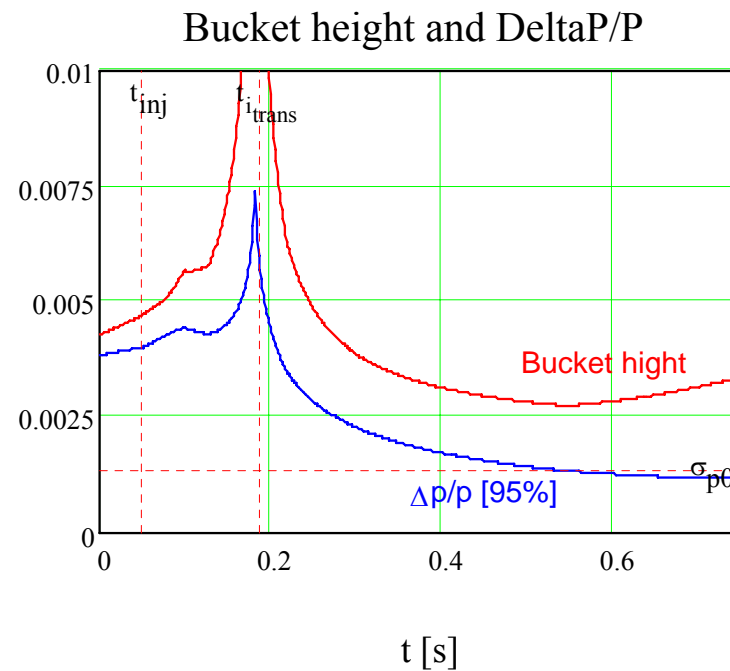
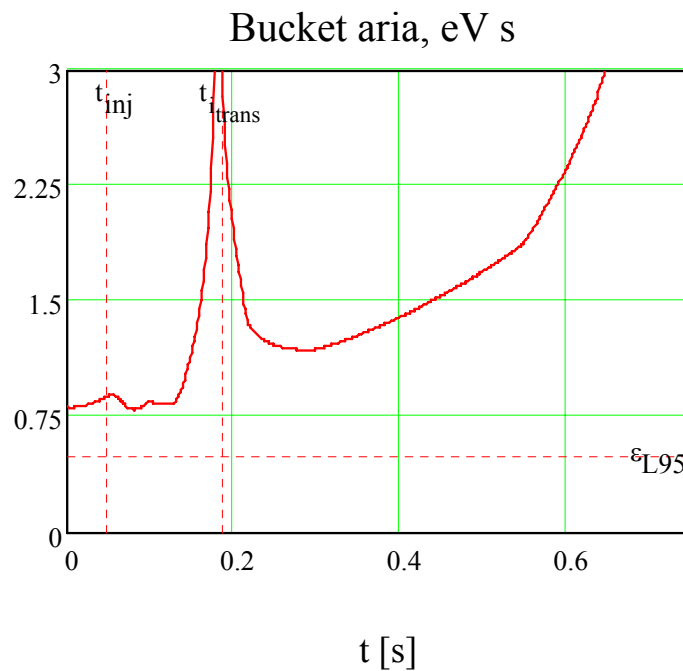
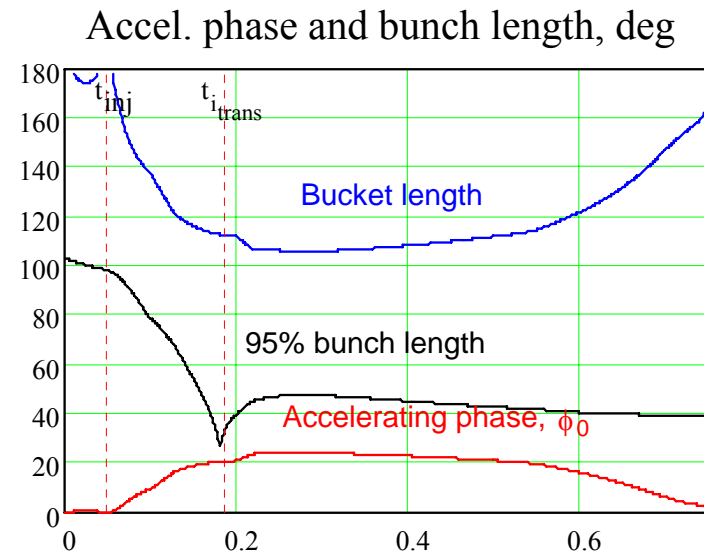
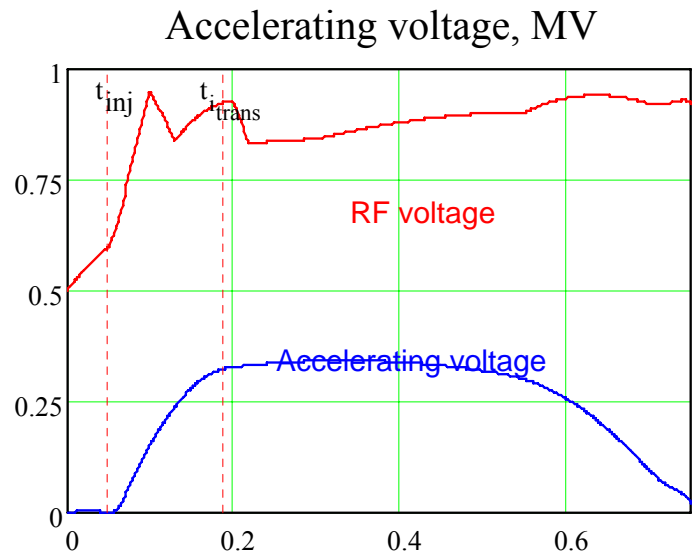
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# Tentative PS-2 parameters and Comparison to FNAL MI

	FNAL Main Injector		PS-2
	Present	New(project X)	
Injection kinetic energy, GeV	8		5
Extraction kinetic energy, GeV	120 (max. 150)		50
Circumference, m	3319.42		~1200
Number of particles per bunch	$7 \cdot 10^{10}$	$3.1 \cdot 10^{11}$	$4 \cdot 10^{11}$
Beam current at injection, A	0.49	2.45	2.5
Cycle duration, s	2.2	1.4	1.5 (3.3?)
Normalized 95% emittance, $\pi$ mm mrad	15/15	25/25 <sup>†</sup>	18
Norm. acceptance at injection, $\pi$ mm mrad	40/40	40/40	100 <sup>‡</sup>
90% longitudinal emittance, eV s/bunch	0.4	0.5	0.5
Total number of particles	$3.4 \cdot 10^{13}$	$1.7 \cdot 10^{14}$	$6.5 \cdot 10^{13}$
$\gamma$ -transition, $\gamma_T$	21.62	21.62	~12
Betatron tunes, $Q_x/Q_y$	26.42/25.41	26.45/25.46	~15
Maximum Coulomb tune shifts, $\Delta Q_x/\Delta Q_y$	0.033/0.038	0.043/0.046	0.07/0.12!!!
Harmonic number	588	588	160
Accelerating frequency, MHz	53	53	40
Average beam power on the target, MW	0.3	2.3	0.37

<sup>†</sup> KV distribution is implied

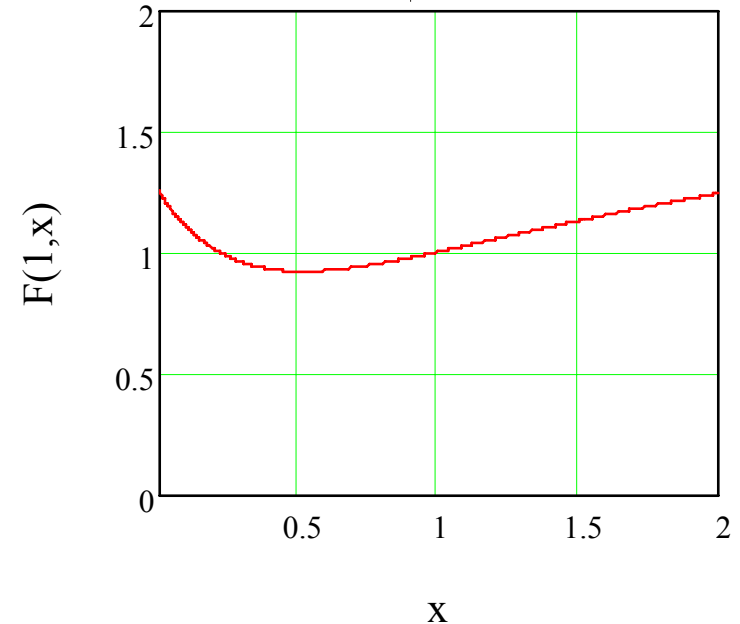
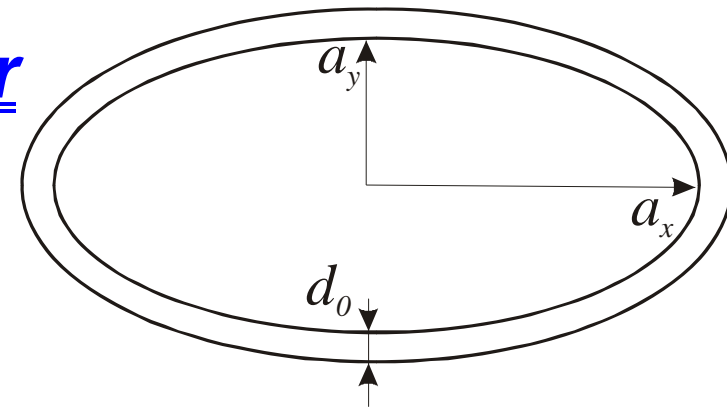
<sup>‡</sup> Vacuum chamber size is set by this acceptance



*Beam parameters for single harmonic acceleration,  $f \sim 40$  MHz*

# Field Screening by Vacuum Chamber

- Beam sizes are set by machine acceptance  
For  $\beta_{max} \approx 40$  m and Normalized acceptances:  $\varepsilon_{xn} \approx \varepsilon_{yn} \approx 100$  mm mrad one obtains sizes:  $a_x \approx 6.2$  cm,  $a_y \approx 2.5$  cm (the same sizes as for FNAL MI)
- Vacuum chamber thickness is limited by currents excited in walls by eddy currents



$$\frac{\delta B}{B} = i \frac{a_x d_0}{\delta^2} F(a_x, a_y), \quad \delta = \frac{c}{\sqrt{2\pi\sigma\omega}} \gg d_0$$

$$F(a_x, a_y) = \frac{4}{\pi} a_y \int_0^{\pi/2} \frac{\sqrt{a_x^4 \sin^2 \varphi + a_y^4 \cos^2 \varphi}}{(a_x^2 \sin^2 \varphi + a_y^2 \cos^2 \varphi)^{3/2}} (\cos \varphi)^2 d\varphi$$

For stainless steel with  $d_0 = 1.3$  mm (FNAL MI)

$$\text{and } f = 1 \text{ Hz} \Rightarrow dB/B \approx 2 \cdot 10^{-4}$$

For aluminum with  $d_0 = 3$  mm (increased because of less rigidity)

$$\text{and } f = 1 \text{ Hz} \Rightarrow dB/B \approx 10^{-2}$$

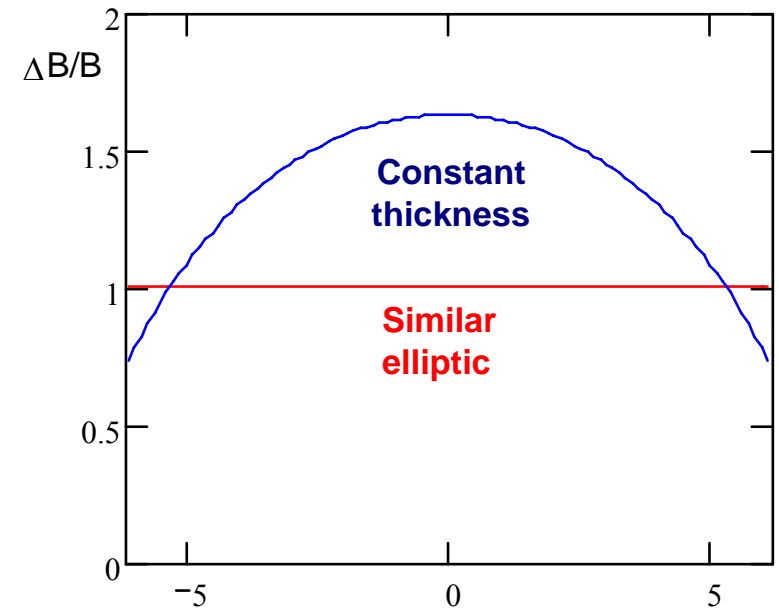
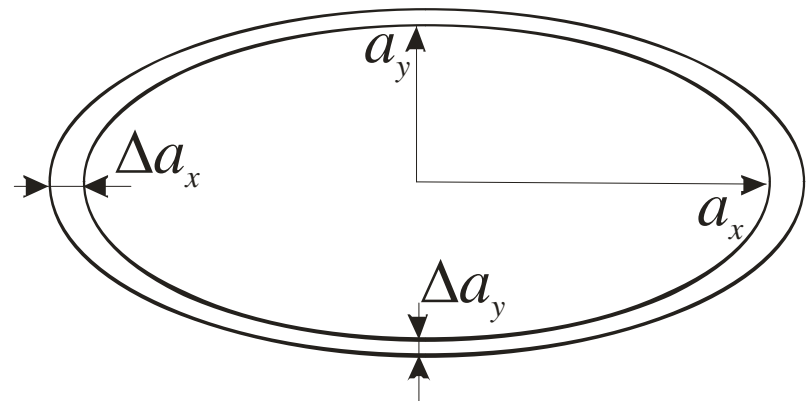
Thus only stainless steel is suitable as the vacuum chamber material

## Elliptic vacuum chamber with similar boundaries

- Elliptic vacuum chamber with similar boundaries attenuates field uniformly

$$\frac{\delta B}{B} = i \frac{2a_x a_y \Delta a_x}{\delta^2 (a_x + a_y)}, \quad \frac{\Delta a_x}{a_x} \equiv \frac{\Delta a_y}{a_y}$$

- That, in principle, allows one to use extruded aluminum vacuum chamber
  - ◆ High accuracy of the chamber profile
    - Time delay of bending magnetic field
  - ◆ Quads still have to be addressed separately
    - Disagreement between quads and dipoles
- This choice does not look attractive from operational points of view but if followed could significantly reduce resistive wall impedance



*Dependence  $\Delta B_y(x,0)$  for similar elliptic and constant width vacuum chambers, arbitrary units,  $\Delta a_x = d_0$*

# Transverse Impedance due to Wall Resistivity

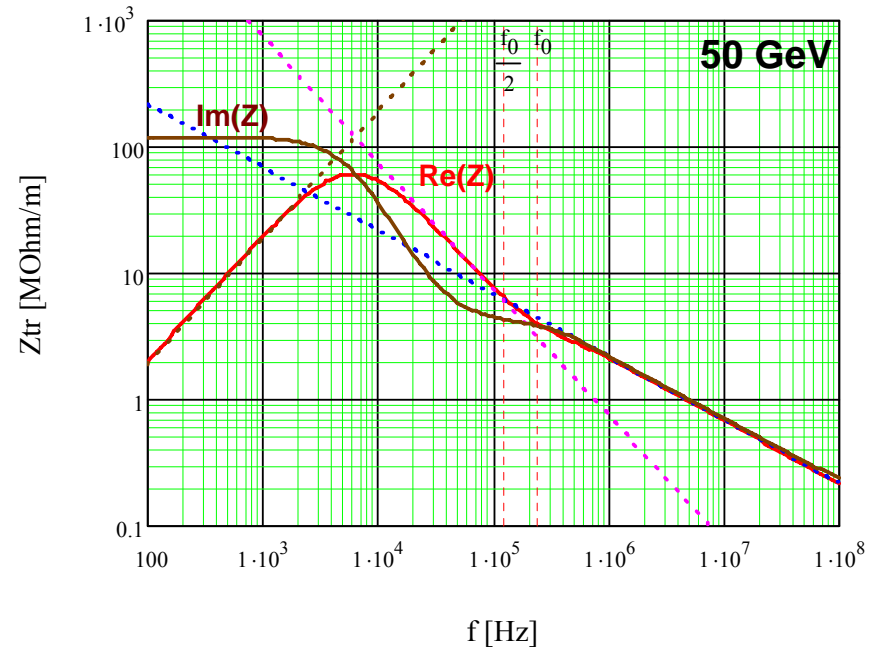
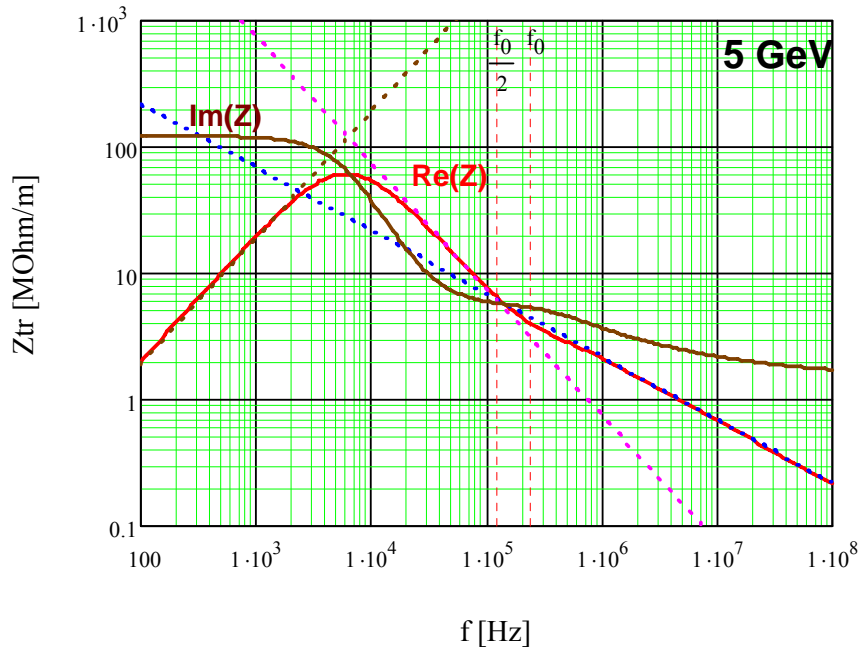
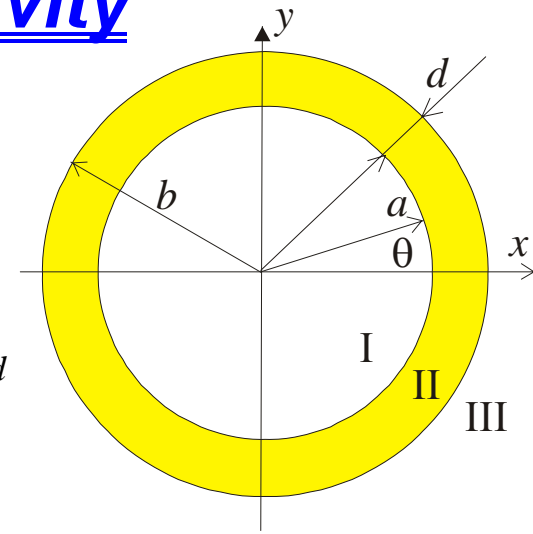
For round vacuum chamber ( $d \ll a, b = a + d$ )

$$Z_{\perp} = -i \frac{Z_0 (2\pi R)}{2\pi a^2} \left[ 2 \frac{e^{kd}(1+kb) - e^{-kd}(1-kb)}{e^{kd}(1+ka)(1+kb) - e^{-kd}(1-ka)(1-kb)} + \frac{1}{\beta} - 1 \right]$$

$$k = \frac{1-i}{\delta}, \quad \delta = \frac{c}{\sqrt{2\pi\sigma\omega}}$$

$$Z_0 = \frac{4\pi}{c} \approx 377$$

$$Z_{\perp} = (2\pi R)Z_0 \begin{cases} \frac{c(1-i)}{2\pi a^3 \sqrt{2\pi\sigma_R\omega}} - \frac{i}{2\pi a^2} \left( \frac{1}{\beta} - 1 \right), & \delta \leq d \\ \frac{c^2}{4\pi^2 \sigma_R \omega a^3 d} - i(\dots), & \sqrt{ad} \geq \delta \geq d \\ \frac{\sigma_R \omega d}{c^2 a} - i \frac{1}{2\pi a^2 \beta}, & \delta \geq \sqrt{ad} \end{cases}$$



*Stainless steel,  $r=a=25$  mm,  $d=1.3$  mm;*

*(20-50)% correction at the lowest betatron sideband due to  $\delta \sim d$*

# Transverse Impedance due to Wall Resistivity (continue)

## Impedance of flat vacuum chamber

$$Z_y = \kappa Z_{\perp}, \quad Z_x = \frac{\kappa}{2} Z_{\perp}, \quad \kappa = \frac{\pi^2}{12} \approx 0.822$$

- ◆ Impedance of elliptic vacuum chamber is close to the flat one

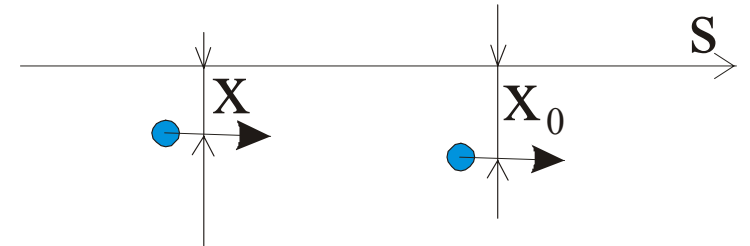
## Detuning Wake

- For round vacuum chamber the beam excites dipole field behind him.  
That corresponds to the normal wake field,  $W(s)$ .
- For non-round vacuum chamber there are quadrupole field and higher multipoles.  
Contribution corresponding to quadrupole field is described by detuning wake  $D(s)$ :

- Detuning wake changes betatron tunes for tail particles

- ◆ For the round vacuum chamber:  $D(s) = 0$  .

- ◆ For the flat vacuum chamber:  $W_x(s) = W_y(s)/2 = -D(s)$

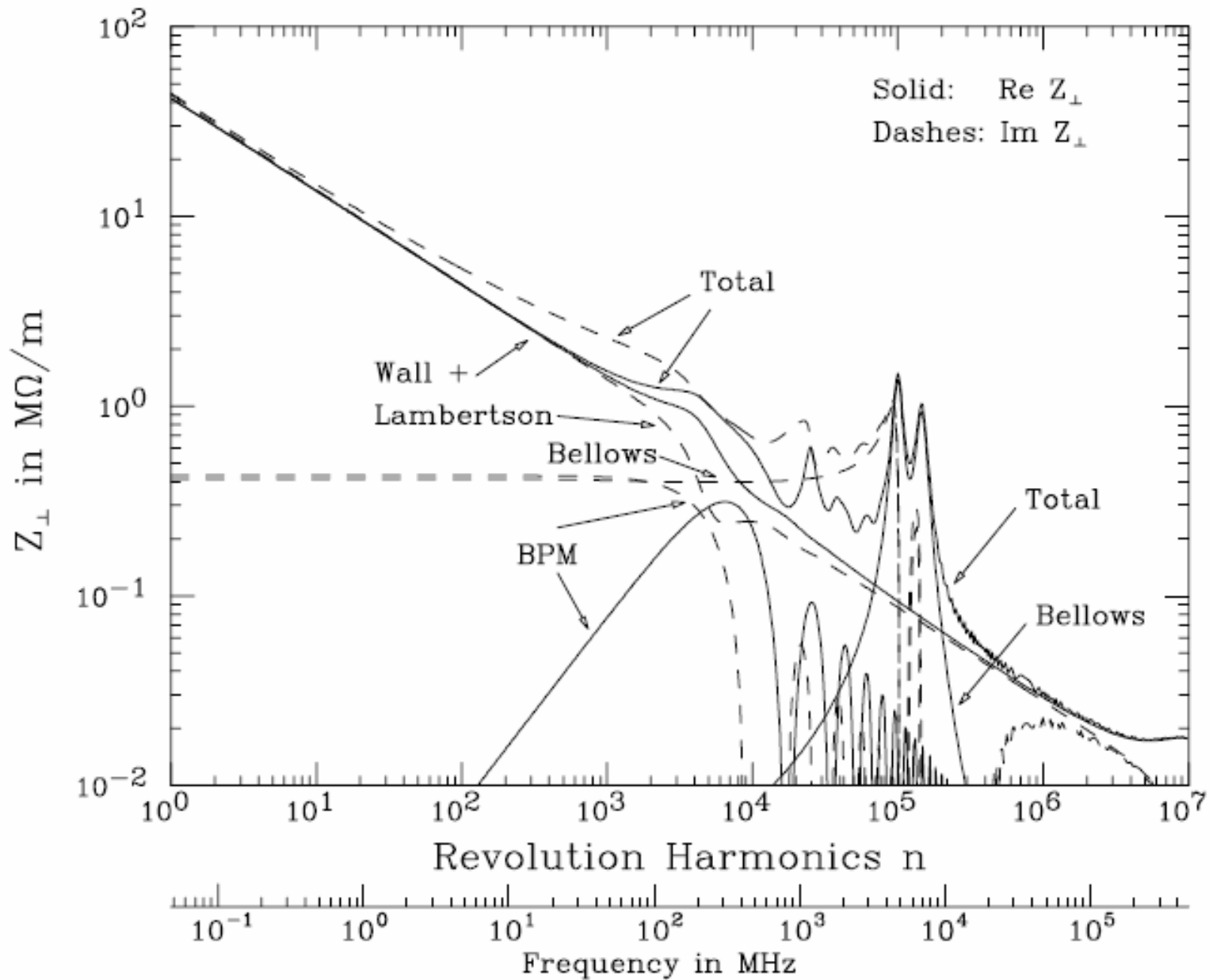


\*A.Burov, V.Danilov "Suppression of transverse instabilities by asymmetries in the chamber geometry," PRL, **82**, 1999, p.2286.

$$\int_L F_x ds' v = e^2 (x_0 W_x(s) + x D(s))$$

$$\int_L F_y ds' = e^2 (y_0 W_y(s) - y D(s))$$





*Tevatron transverse impedance estimate at the Run II beginning, Run IIA handbook (B.Ng), 2001*

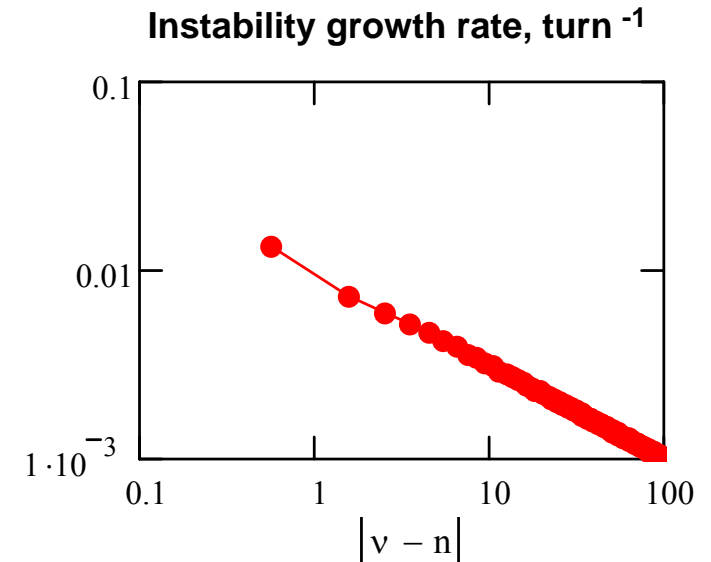
- Tevatron has stainless steel vacuum chamber
  - ◆ Wall resistivity dominates  $Z_{\perp}$  at frequencies below 100 MHz

# Transverse Instability at the Lowest Betatron Sidebands

- Resistive wall impedance is dominating at low frequencies
- For a flat vacuum chamber the coherent tune shift is

$$\Delta \nu_{y_n} = -\frac{1+i}{96\pi} \frac{eI_0 C^{5/2}}{mc^2 \gamma \beta^2 v a_y^3 \sqrt{\sigma_R c(n-\nu)}}$$

- ◆ Assume
  - zero tune spread ( $d\nu/dp = 0$ )
  - $d \gg \delta$
- For FNAL Project-X the instability due to resistive wall impedance has growth time of 10 turns
- It is not a problem for PS-2 due to smaller ring size (smaller energy)
  - ◆ Growth time  $\sim 30$  turns
- Present bunch-by-bunch damper at FNAL MI damps betatron motion during  $\sim 70$  turns
  - ◆ There should not be a problem to do something similar for PS-2
- Landau damping damps high frequency modes



*Instability growth rate at injection for different transverse modes*

## Ways to Reduce Resistive Wall Impedance, $Z_{\perp}$

- If required there are 2 ways to reduce impedance
  - ◆ Thin conductive layer on the inner wall of vacuum chamber
  - ◆ Larger aperture
- Both methods increase screening of the alternate bending field
- At the lowest betatron sideband the thin conductive layer equally affects screening and impedance
  - ◆ but it does much better job at high frequencies
- Larger aperture affects the impedance much stronger ( $a^3/d \sim a^2$ ) than the shielding ( $\sim a$ )

# Wideband Longitudinal Impedance

- At low energy and transition crossing the impedance is dominated by the space charge

$$\frac{Z_n}{n} = i \frac{Z_0}{\beta\gamma^2} \ln\left(\frac{a_y}{1.06\sigma}\right)$$

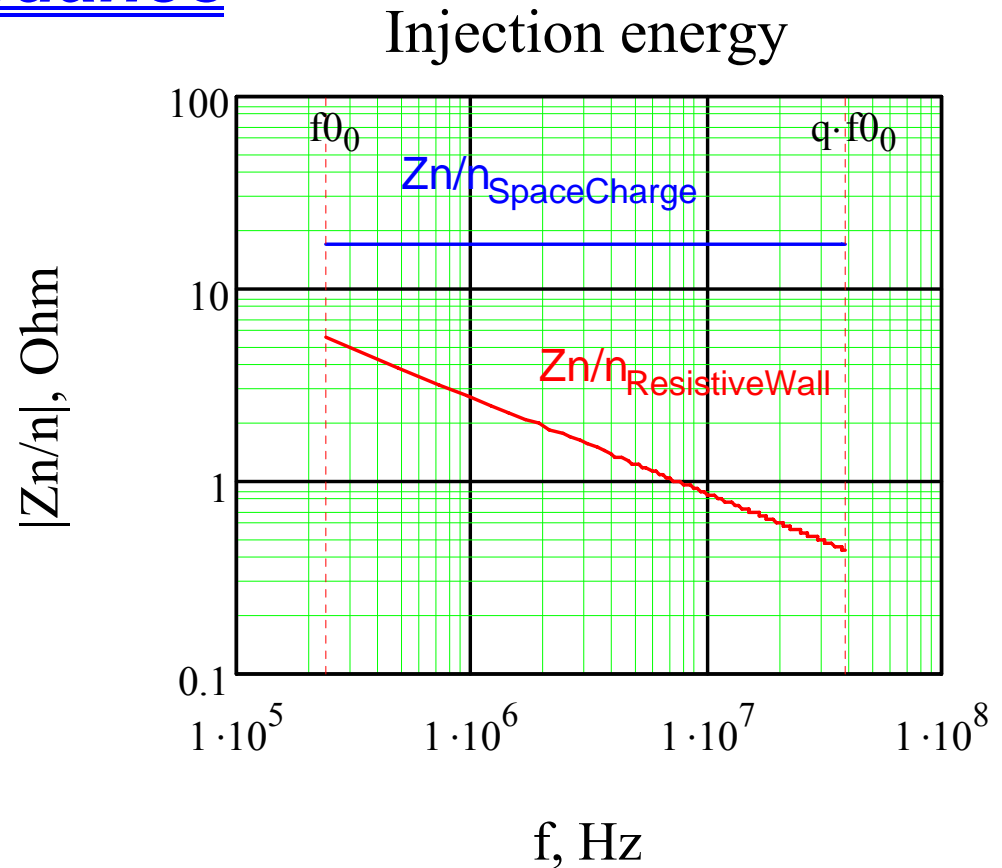
- Resistive wall makes the second largest contribution at small frequencies,  $f \leq 100$  MHz

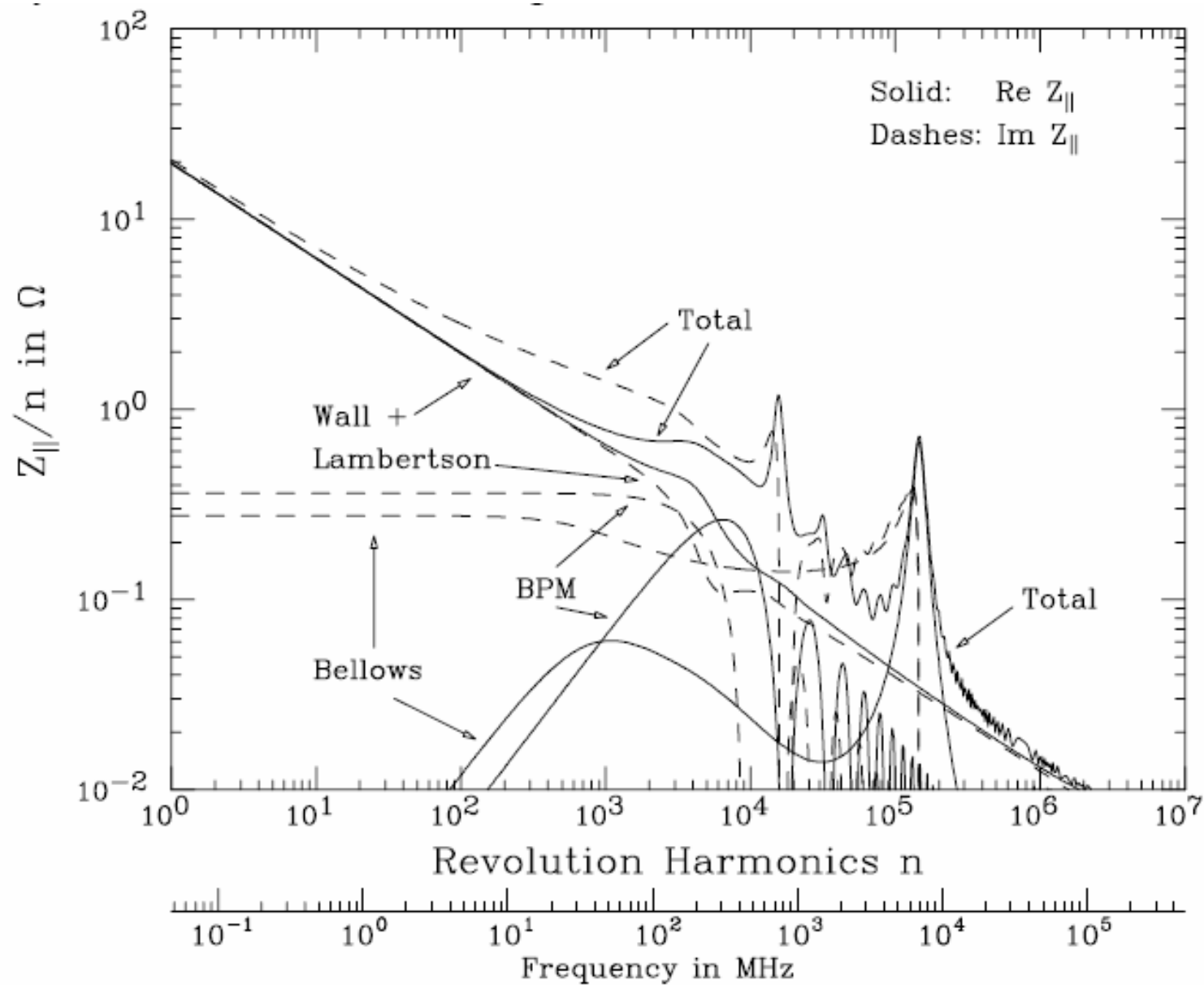
$$\frac{Z_n}{n} = (1-i)\kappa \frac{Z_0}{4\pi a_y} C \sqrt{\frac{n\omega_0}{4\pi\sigma_R}}$$

$\kappa = 1$  and  $\kappa \approx 0.8$  are for round and flat vacuum chambers, correspondingly

$C$  - machine circumference

$\sigma_R$  - wall conductivity



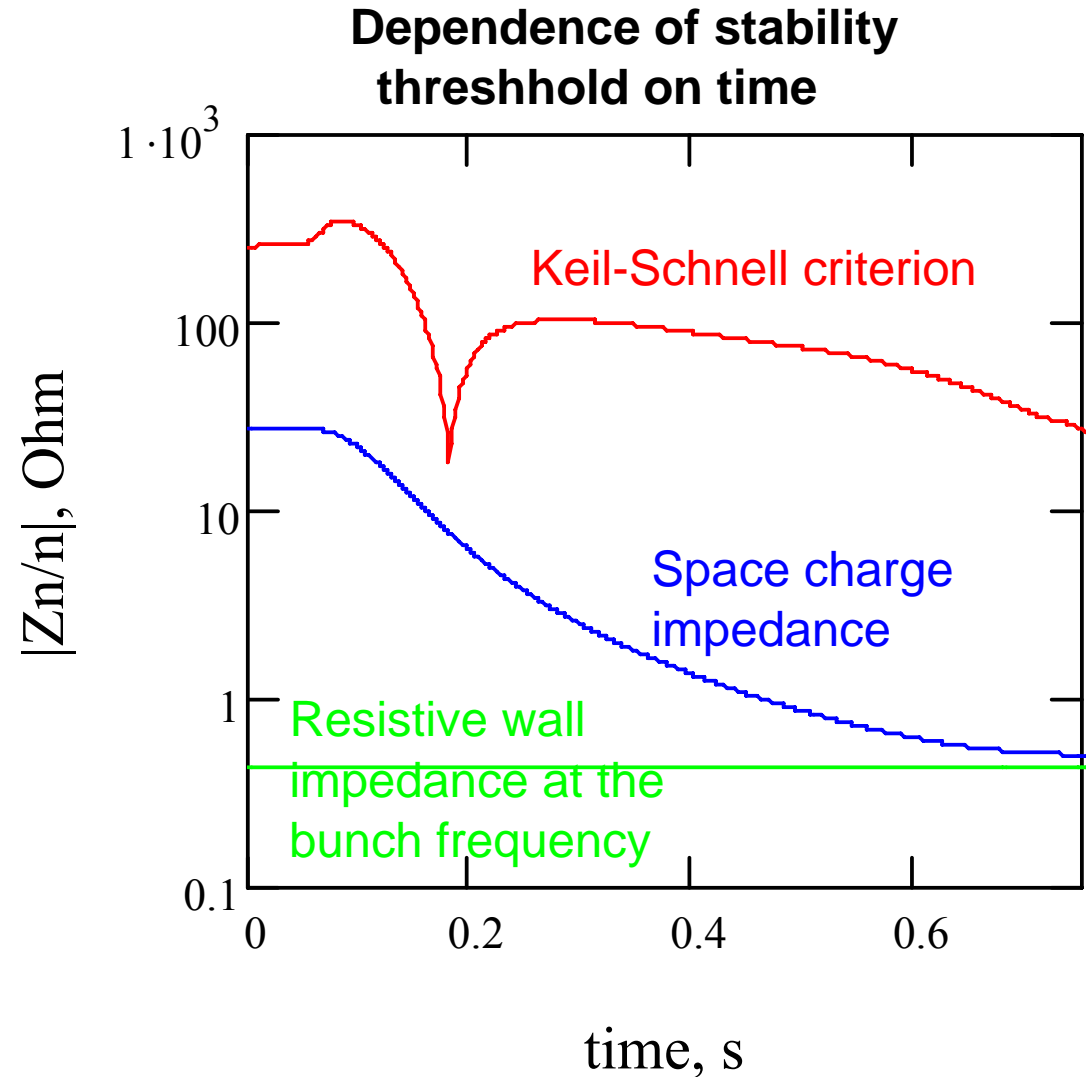


*Tevatron longitudinal impedance estimate at the Run II beginning, Run IIA handbook (B. Ng), 2001*

- At high frequencies ( $f \geq 100$  MHz) vacuum chamber interruptions begin dominating the impedance

# Longitudinal beam stability

- Wide band longitudinal impedance is sufficiently small and should not be a problem
- Interaction with RF cavities can cause beam instability
  - ◆ Bunch-by-bunch damper can address the problem



# Other concerns

- Coulomb tune shifts look too large
    - ◆ Larger dispersion (smaller tunes) can increase horizontal beam size and partially alleviate the problem
- For equal tunes and emittances in smooth approximation

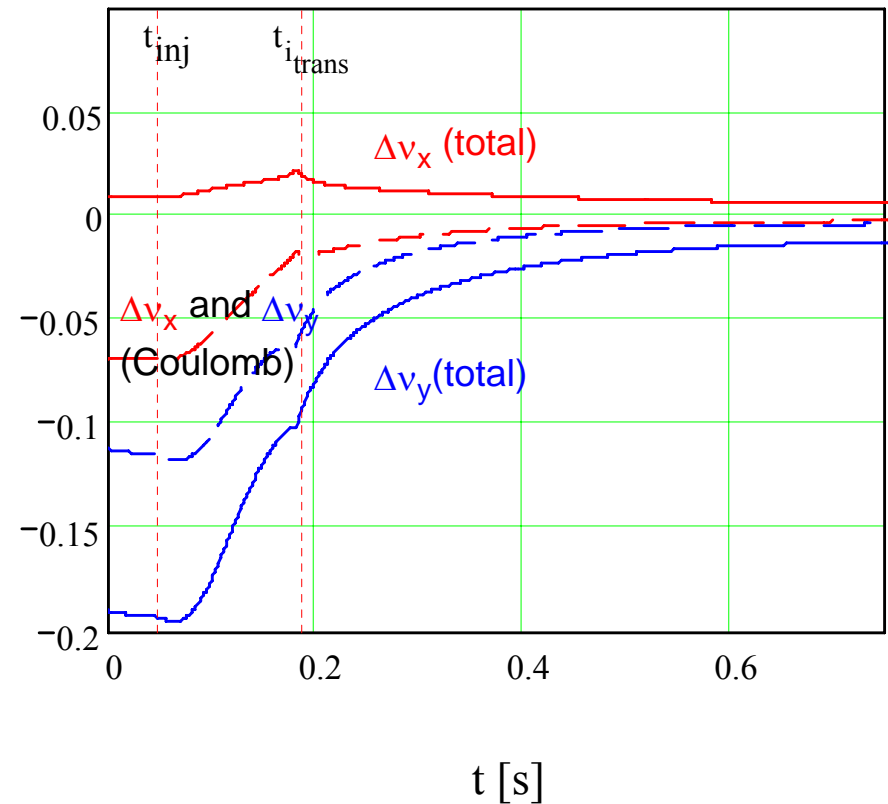
$$\Delta \nu_y = \frac{r_p N}{2\pi\beta^2\gamma^3\epsilon} \frac{1}{\left(1 + \sqrt{1 + \frac{R\sigma_p^2}{\epsilon V^3}}\right)}$$

$$\Delta \nu_x = \frac{r_p N}{2\pi\beta^2\gamma^3\epsilon} \frac{1}{\sqrt{1 + \frac{R\sigma_p^2}{\epsilon V^3}} \left(1 + \sqrt{1 + \frac{R\sigma_p^2}{\epsilon V^3}}\right)}$$

$\Delta \nu_y$  still will be a problem but vertical resonance driving terms will be reduced if  $\sigma_x \gg \sigma_y$

- Incoherent tune shifts due to interaction with the vacuum chamber can be corrected by machine quads (we use it in MI)

Incoherent tune shifts



# Limitations on the RF system

- RF frequency is chosen to coincide with LHC bunch frequency
  - ◆ Similar to the FNAL Project-X
  - ◆ May be not the best choice from ep multipactoring
  - ◆ RF gymnastics can be used to shorten bunches before extraction so that they could be caught by 200 MHz of next machine
  - ◆ Second harmonic RF would be helpful to reduce peak long. density at injection and achieve better Landau damping
- Power and voltage are set by the acceleration and the number of particles
- Feed forward system will be required to suppress abort gap influence on RF parameters

Harmonic number	160
Frequency, injection to extraction, MHz	39.6-40.2
Total RF voltage, MV	1
Number of cavities	6
Shunt impedance per cavity, $(R/Q)*Q$ , k $\Omega$	100
Loaded Q	4000
Peak RF power, MW	1.6
Max. power transferred to the beam, MW	0.9
Voltage induced by the beam, MV	1.5



## Conclusions

- To ensure reliable operation of PS-2 with beam current of  $\sim 2.5$  A one needs to minimize the machine impedances
- For comparatively short cycle time of  $\sim (1 - 3)$  s the eddy currents limit the vacuum chamber conductivity. Taking into account the mechanical stability of the vacuum chamber the elliptical stainless steel vacuum chamber looks as a preferable choice
  - ◆ Covering it with thin layer of better conducting material (gold, silver or copper) would be helpful but is rather a question of choice than a necessity. To prevent the domination of bending field screening by this layer its thickness should not exceed 30-50  $\mu\text{m}$ 
    - $\sigma_1/\sigma_2$  gain in the impedance will be only for high enough frequencies,  $\geq 20$  MHz
    - Impedance at revolution frequency will be set by limitation on the bending field screening

- To keep the impedance at minimum
  - ◆ Good electromagnetic screening of bellows and other interruptions of the vacuum chamber
  - ◆ Do not use septum magnets with laminations seen by the beam
    - We fixed this problem with Tevatron. MI is next in line
- There are no fundamental limitations on the vacuum chamber impedance for PS-2 parameters
  - ◆ Use of transverse and longitudinal dampers is the must